



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## \*BIBDATASHEET\*

CONFIRMATION NO. 4963

Bib Data Sheet

SERIAL NUMBER 10/649,599	FILING DATE 08/26/2003  RULE	CLASS 250	GROUP ART UNIT 2881	ATTORNEY DOCKET NO. 021773-000310US
-----------------------------	---------------------------------------	--------------	------------------------	---

## APPLICANTS

Jack Y. Jau, Los Altos, CA;

Zhongwei Chen, San Jose, CA;

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/668,697 09/22/2000 PAT 6,710,342 JK

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

None JK

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 11/15/2003

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: JK				

## ADDRESS

20350  
 TOWNSEND AND TOWNSEND AND CREW, LLP  
 TWO EMBARCADERO CENTER  
 EIGHTH FLOOR  
 SAN FRANCISCO, CA  
 94111-3834

## TITLE

Method and apparatus for scanning semiconductor wafers using a scanning electron microscope

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
		<input type="checkbox"/> 1.16 Fees ( Filing )
		<input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )